Application/Control No. O9/491,429 Examiner Armando Rodriguez Applicant(s)/Patent Under Reexamination HEANUE ET AL. Page 1 of 1

Notice of References Cited

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6018535	01-2000	Maeda	372-20
	В	US-5771252	06-1998	Lang et al	372-20
	С	US-2001/0036206 /	11-2001	Jerman et al	372-20
	D	US-			
	Е	US-			
	F	US-			
-	G	US-			
	Н	US-			
	-	US-		**************************************	
	J	US-			
	К	US-			
	L	US-		,	
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Z					
	0					
	Р					
	Q					
	R					
	s					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U	Akimoto et al, Micro electro mechanical systems (MEMS) and their photonic application, SPIE Proceedings, vol. 3098, September 1997, pp. 374-381.				
	v					
	w					
	х					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.